	Application No.	Applicant(s)	
Notice of Allowability	10/820,748 Examiner	RYU ET AL. Art Unit	
	VINH P. NGUYEN	2829	
	VINT P. NGOTEN	2029	
The MAILING DATE of this communication appelaims being allowable, PROSECUTION ON THE MERITS IS ewith (or previously mailed), a Notice of Allowance (PTOL-85) TICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Re Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in) or other appropriate commu (IGHTS. This application is s	this application. If not included nication will be mailed in due c	d ourse. THIS
This communication is responsive to <u>08/10/05</u> .			
☑ The allowed claim(s) is/are <u>1 and 3-28</u> .			
☐ The drawings filed on <u>09 April 2004</u> are accepted by the E	xaminer.		
☐ Acknowledgment is made of a claim for foreign priority ur	nder 35 U.S.C. § 119(a)-(d) o	or (f).	
a) ☑ All b) ☐ Some* c) ☐ None of the:	J	• •	
1. Certified copies of the priority documents have	e been received.		
2. Certified copies of the priority documents have	e been received in Application	n No	
3. Copies of the certified copies of the priority do	ocuments have been received	in this national stage applicati	on from the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
pplicant has THREE MONTHS FROM THE "MAILING DATE" ted below. Failure to timely comply will result in ABANDONN HIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requ	uirements
A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF
CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) I including changes required by the Notice of Draftspers	son's Patent Drawing Review	(PTO-948) attached	
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date	<u>.</u>		
(b) ☐ including changes required by the attached Examiner' Paper No./Mail Date	's Amendment / Comment or	in the Office action of	
dentifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	1.84(c)) should be written on th the header according to 37 CF	e drawings in the front (not the l R 1.121(d).	back) of
DEPOSIT OF and/or INFORMATION about the depo			ote the
attached Examiner's comment regarding REQUIREMENT	FOR THE DEPOSIT OF BIC	PLOGICAL MATERIAL.	
nchment(s)	5 □ Notice of Int	ormal Patent Application (PTO)_152\
Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948)		ımmary (PTO-413),	102)
	Paper No./	Mail Date	
Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date <u>0404,0805</u>	_	Amendment/Comment	
Examiner's Comment Regarding Requirement for Deposit		Statement of Reasons for Allov	vance
of Biological Material	9. 🗍 Other	VINH P NGUYEN Primary Examiner	

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1. The following is an examiner's statement of reasons for allowance:

The prior art does not disclose a semiconductor inspecting apparatus having a combination of a match plate, a radiator with a heat sink, a heat flat pusher and a heat pipe located inside the heat flat pusher for transferring the heat from the semiconductor device to the heat sink via the contact pusher as recited in claims 1,21,22 in combination with other features of claims 3-17,23-28.

The prior art does not disclose a radiator for a semiconductor inspecting device having a combination of a heat sink, a contact pusher to contact a semiconductor device, a heat pipe with working fluid disposed between the heat sink and the contact pusher for transferring heat from contact pusher to the heat sink as recited in claim 18 in combination with other features of claims 19-20.

2. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to VINH P. NGUYEN whose telephone number is 571-272-1964. The examiner can normally be reached on 6:30AM-4:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

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supervisor, Nestor Ramirez can be reached on 571-272-2034. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

VINH P NGUYEN

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Primary Examiner

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08/26/05